

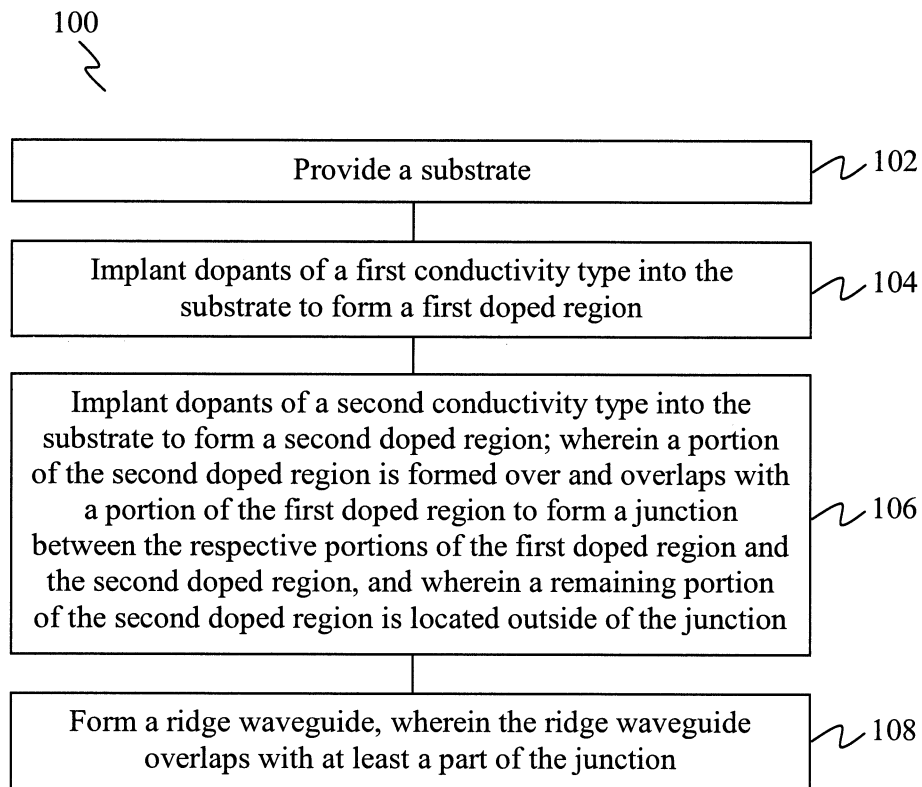


FIG. 1

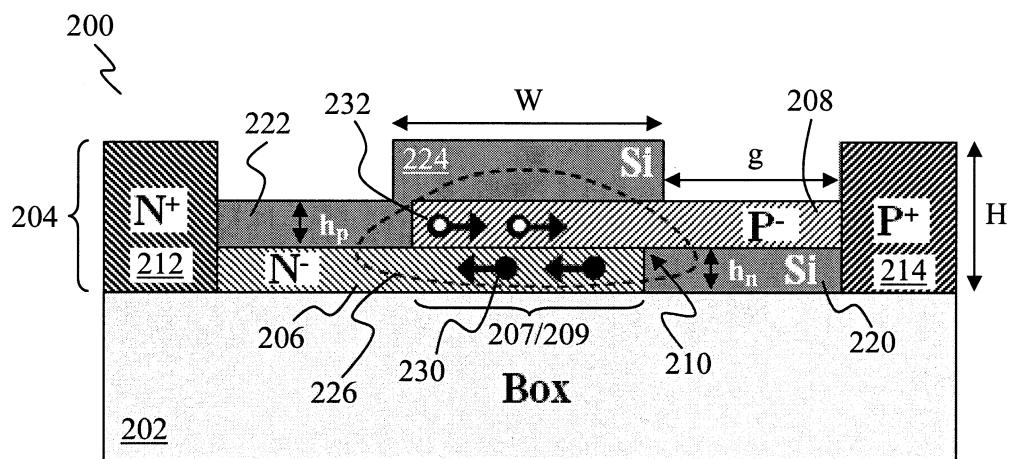


FIG. 2A

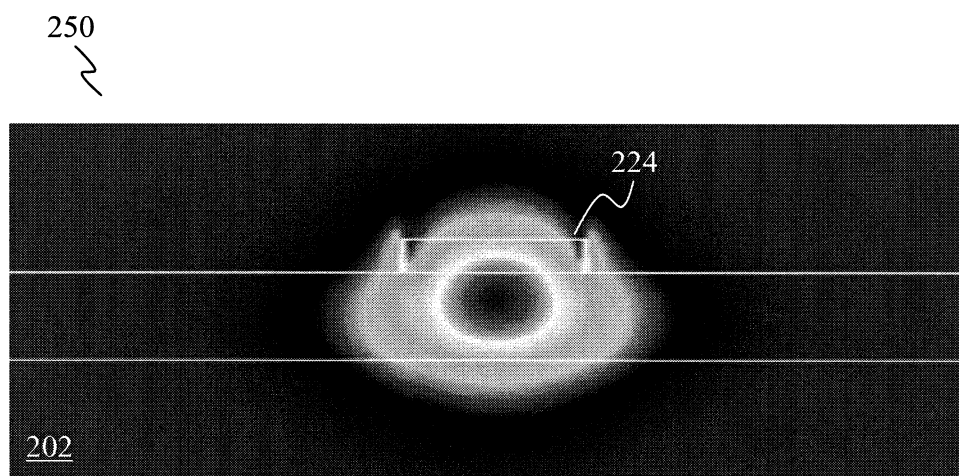


FIG. 2B

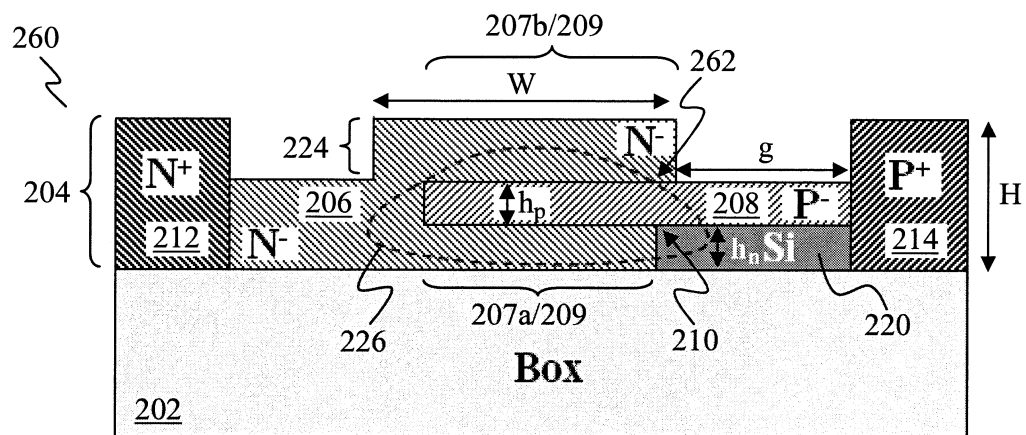


FIG. 2C

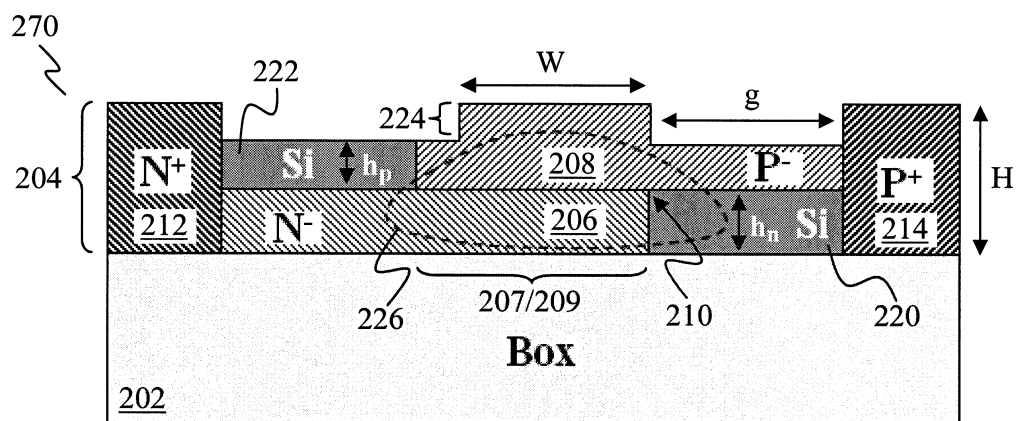


FIG. 2D

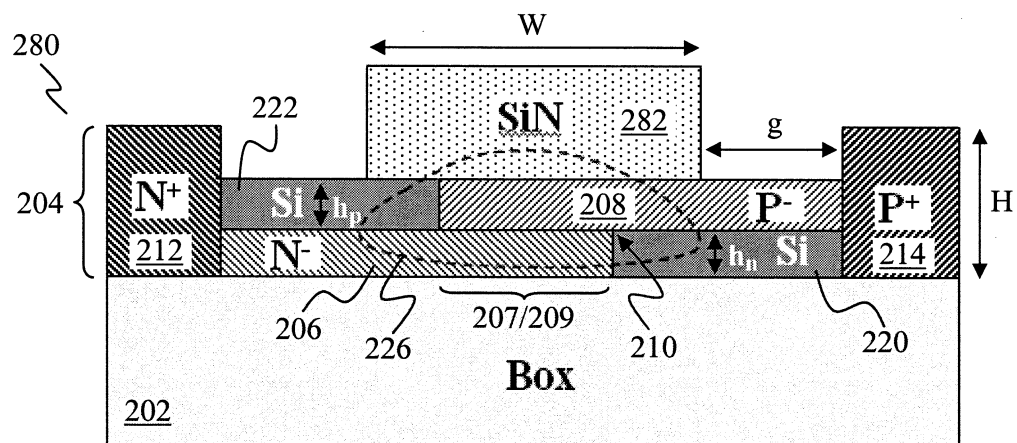
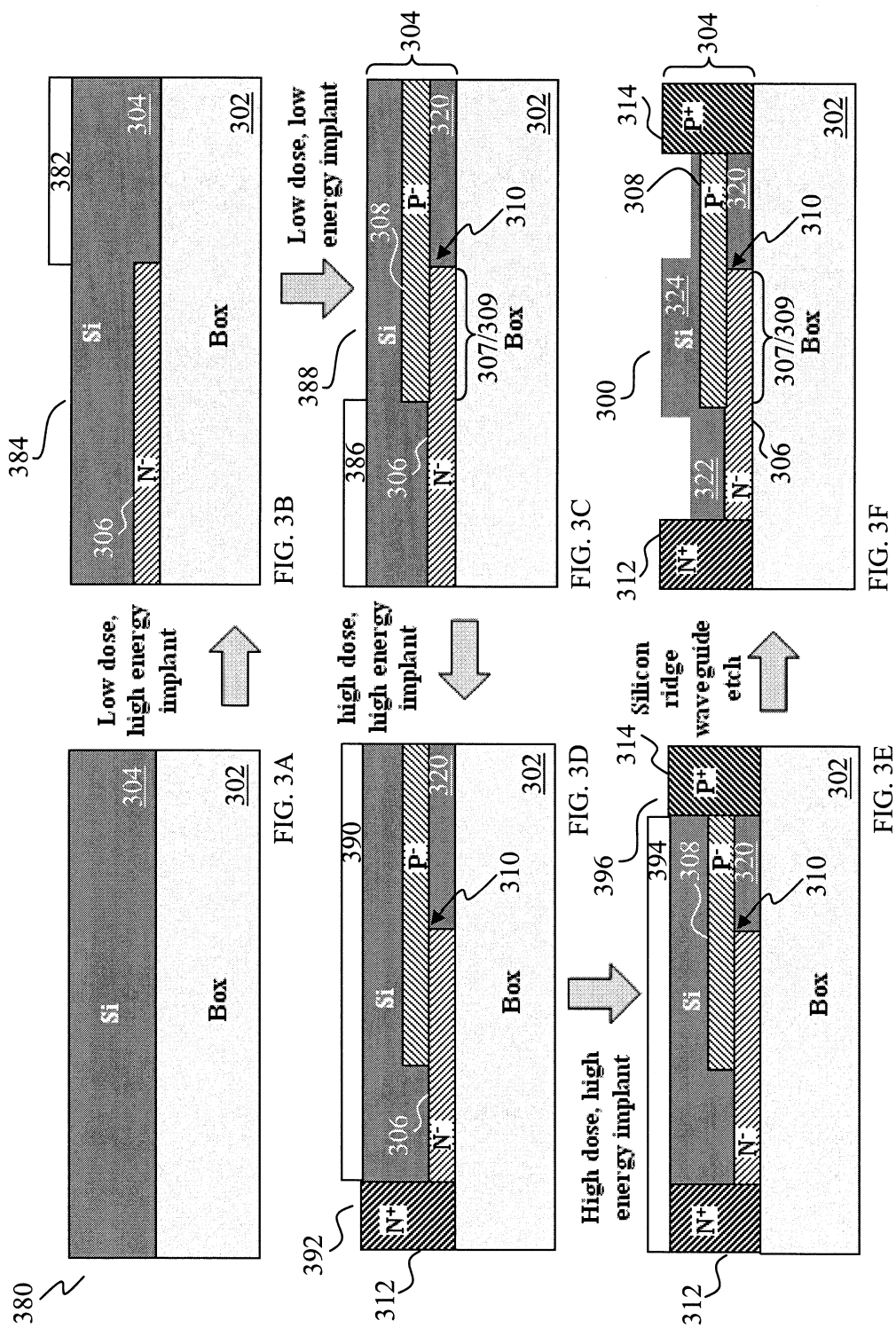
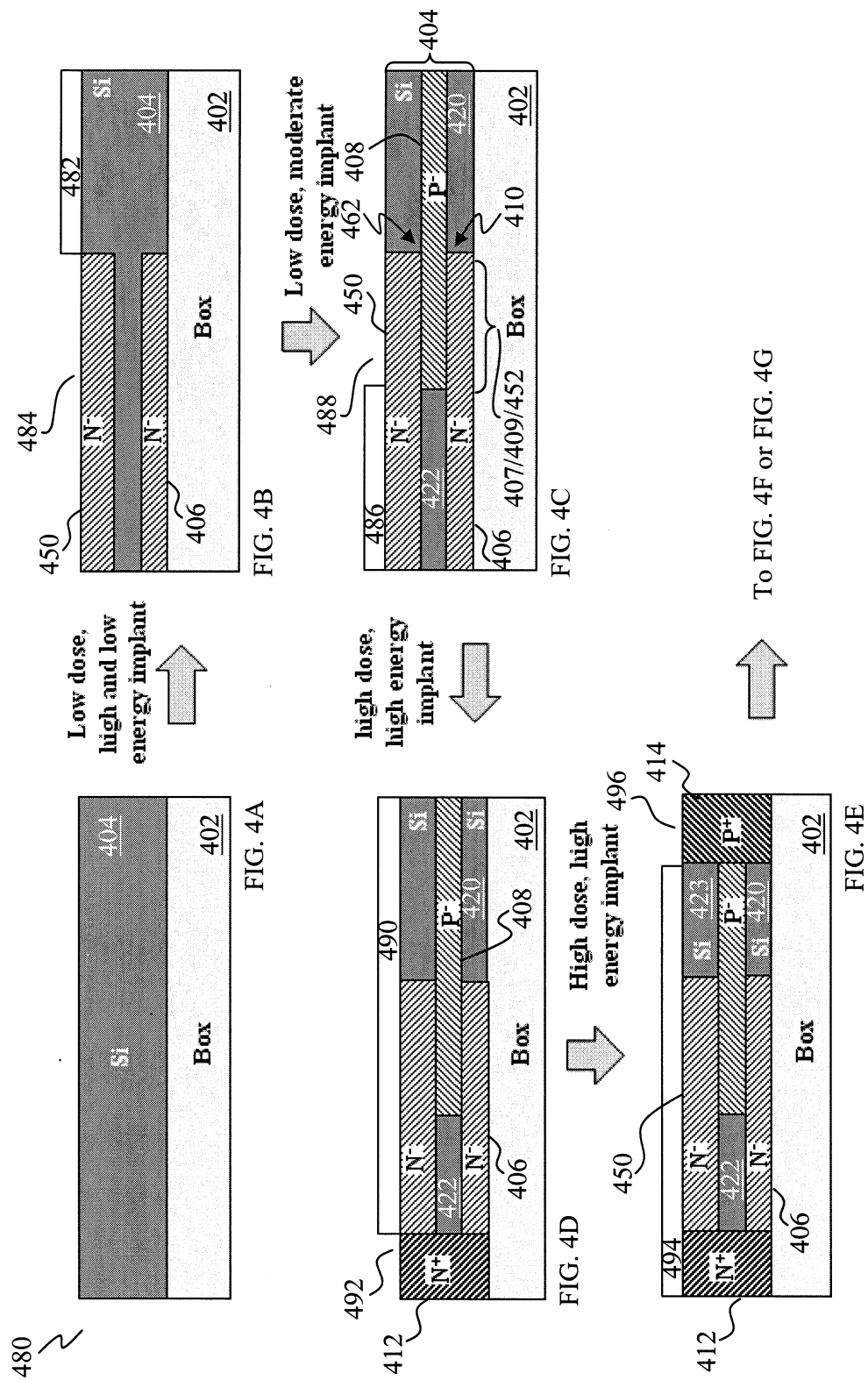
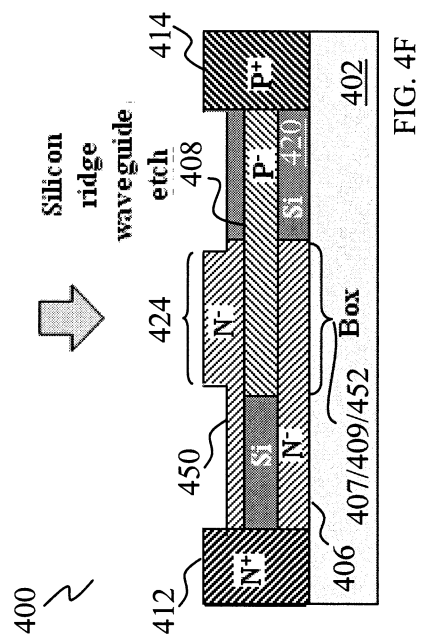
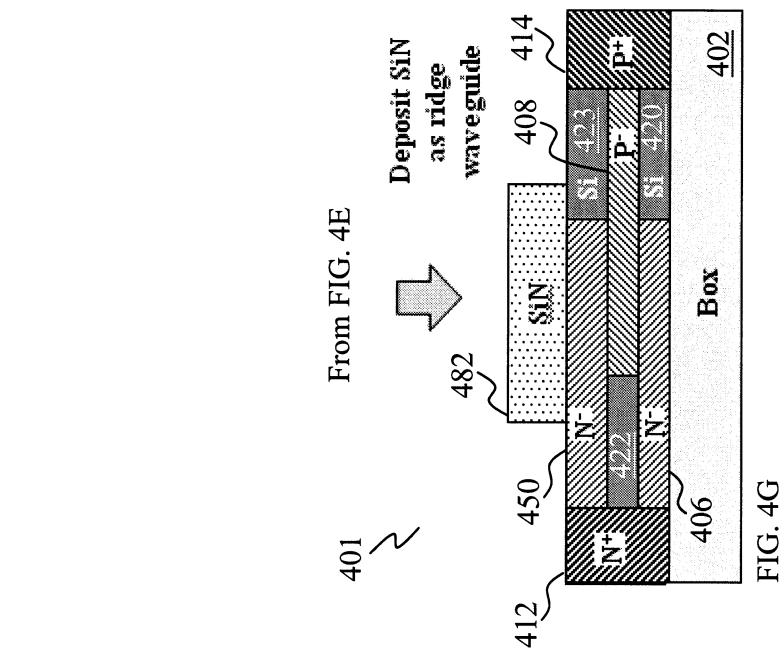
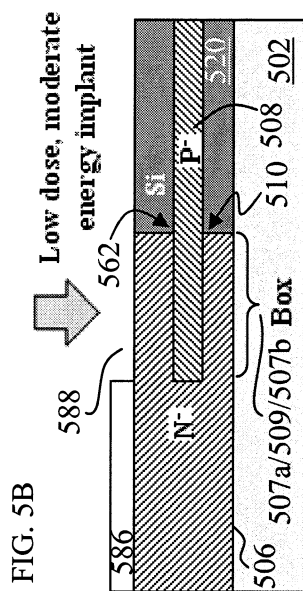
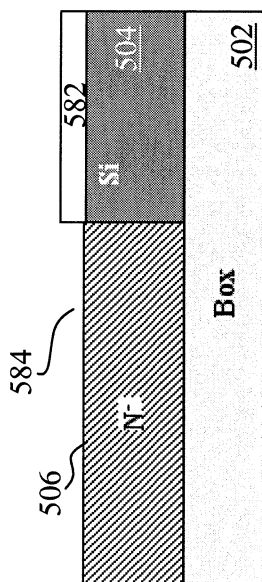


FIG. 2E



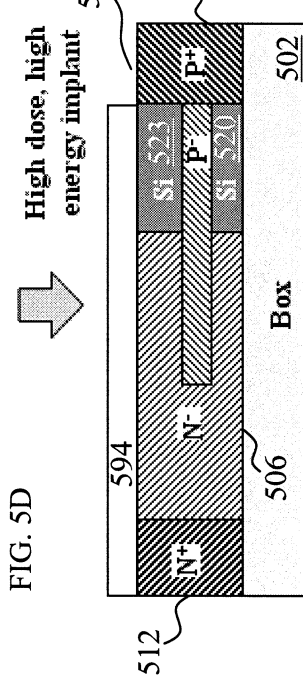
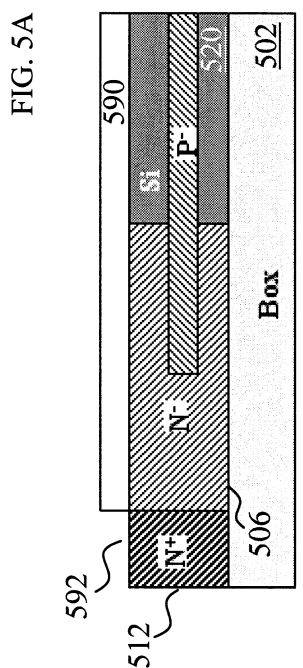
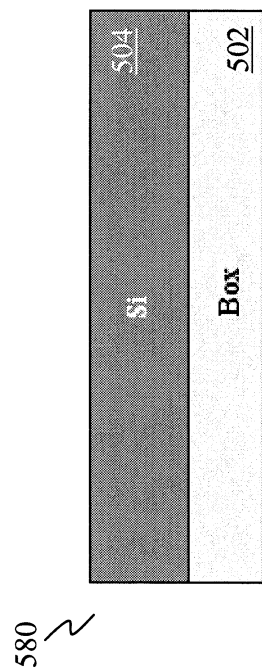






Low dose,
high and low
energy implant

high dose,
high energy
implant



To FIG. 5F or FIG. 5G

From FIG. 5E

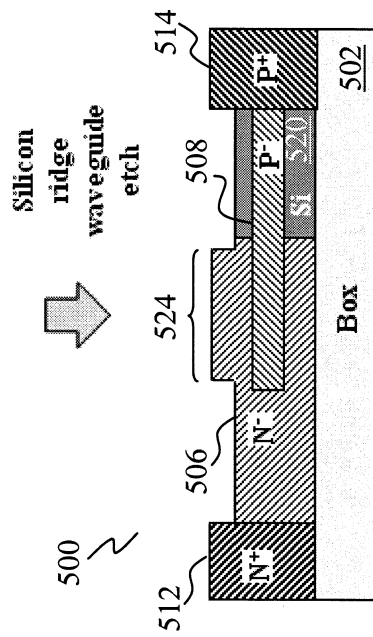


FIG. 5F

From FIG. 5E

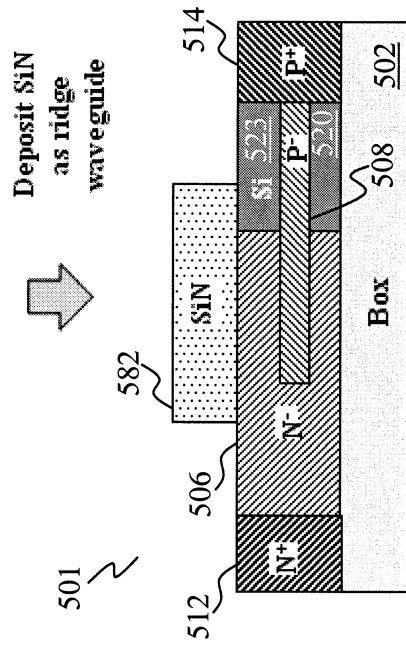
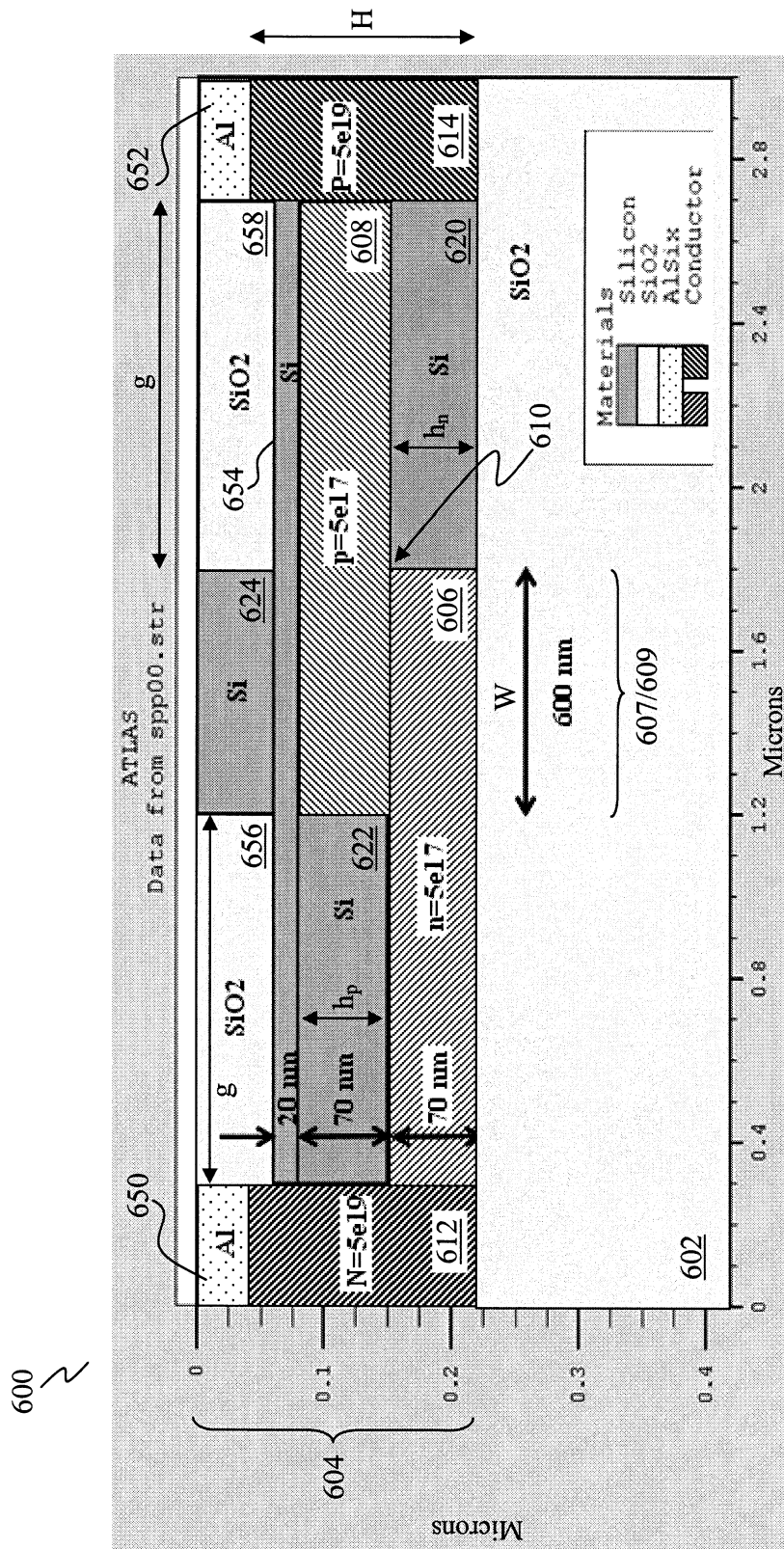


FIG. 5G



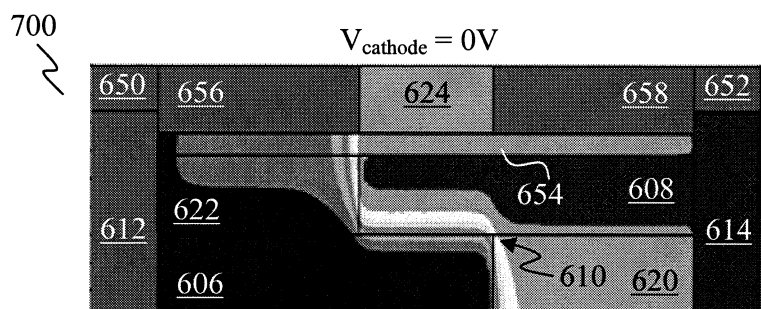


FIG. 7A

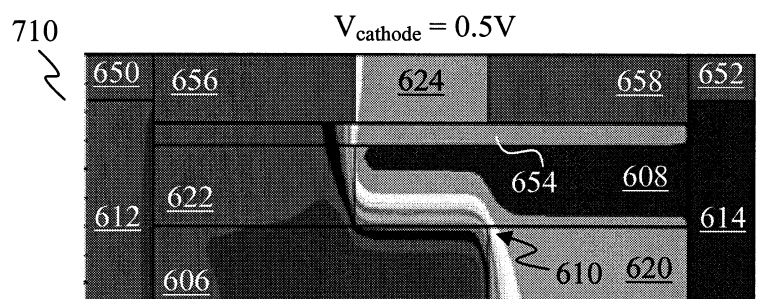


FIG. 7B

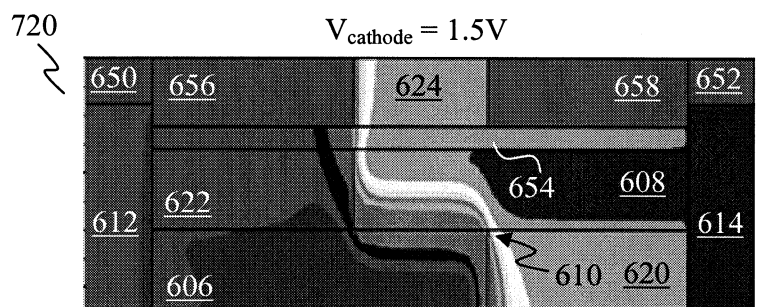


FIG. 7C

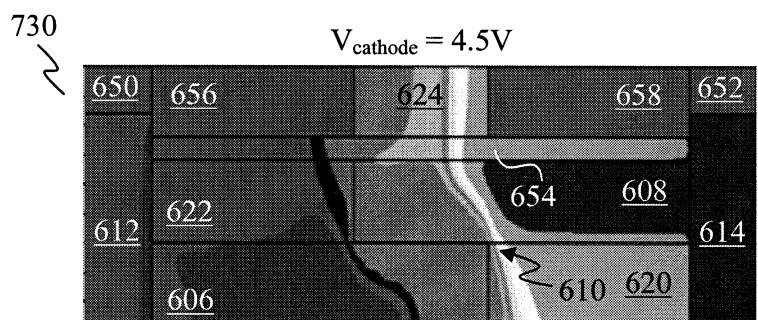
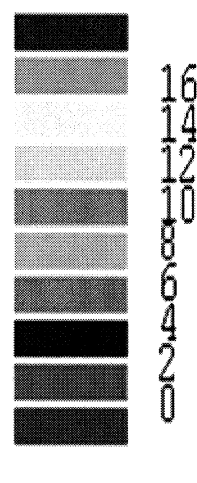
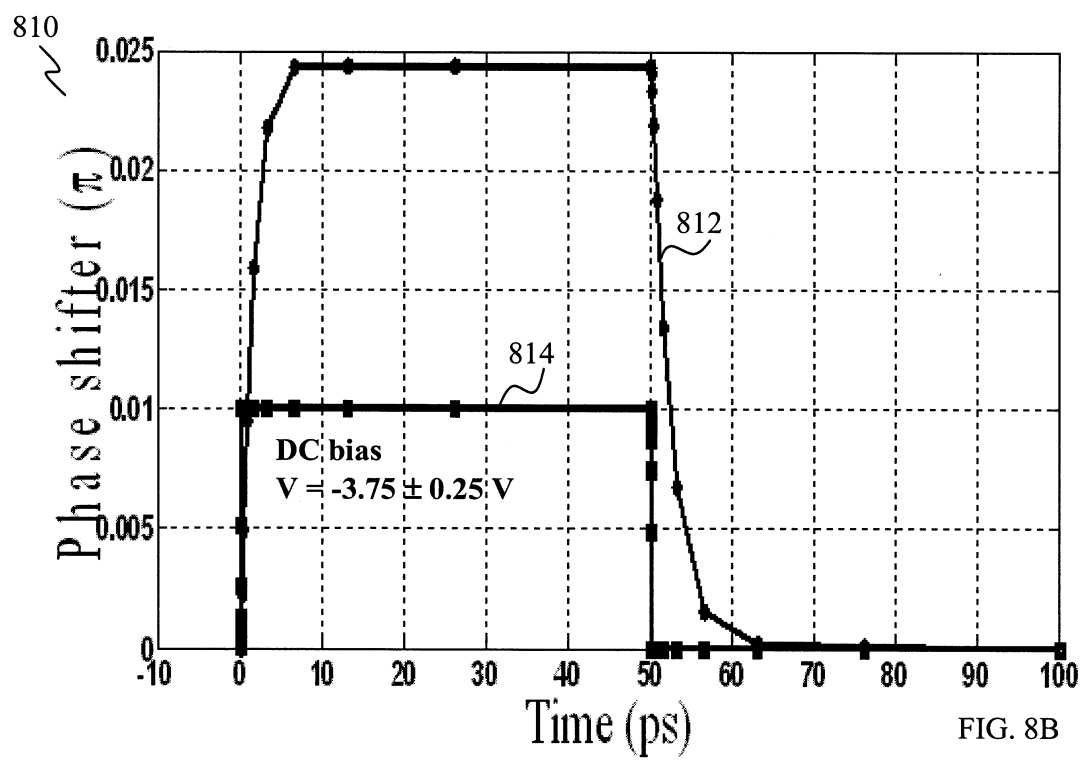
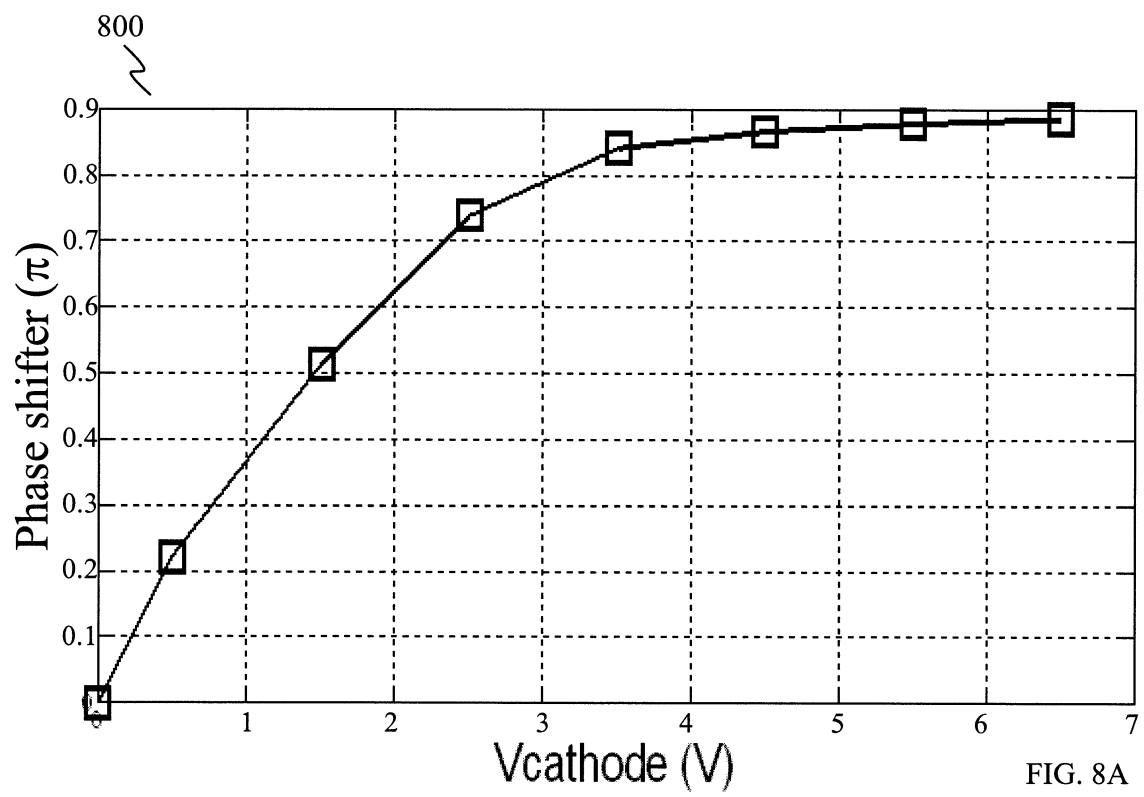


FIG. 7D

Hole concentration
(cm^{-3})





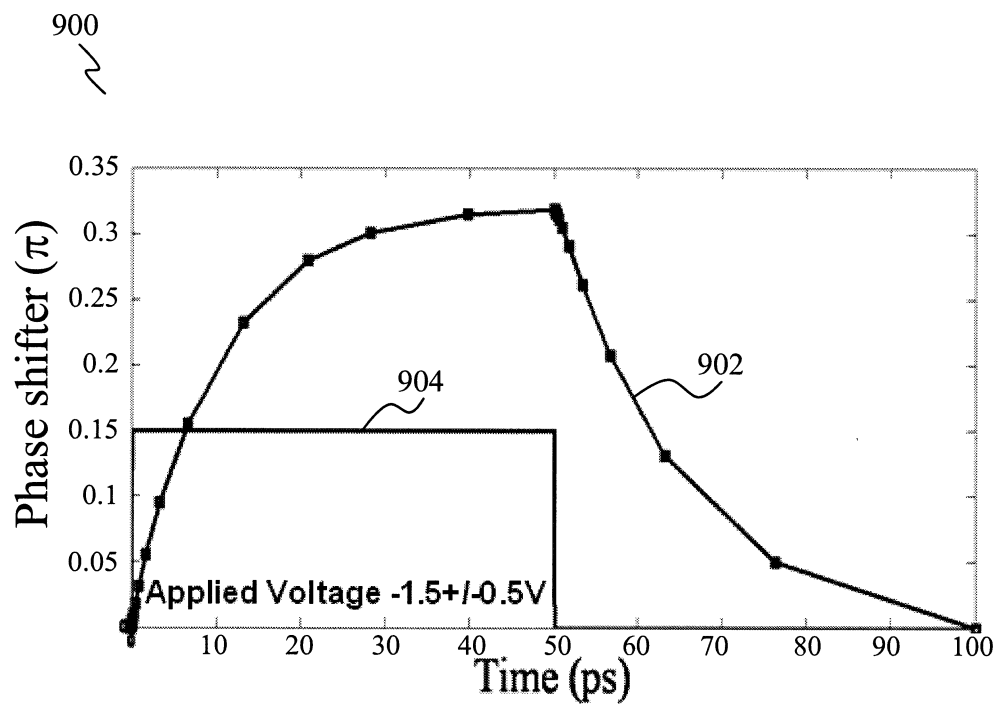


FIG. 9A

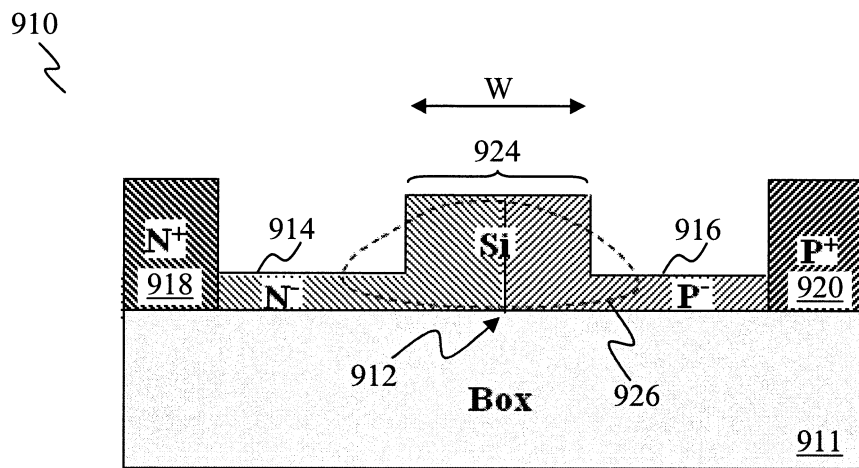


FIG. 9B

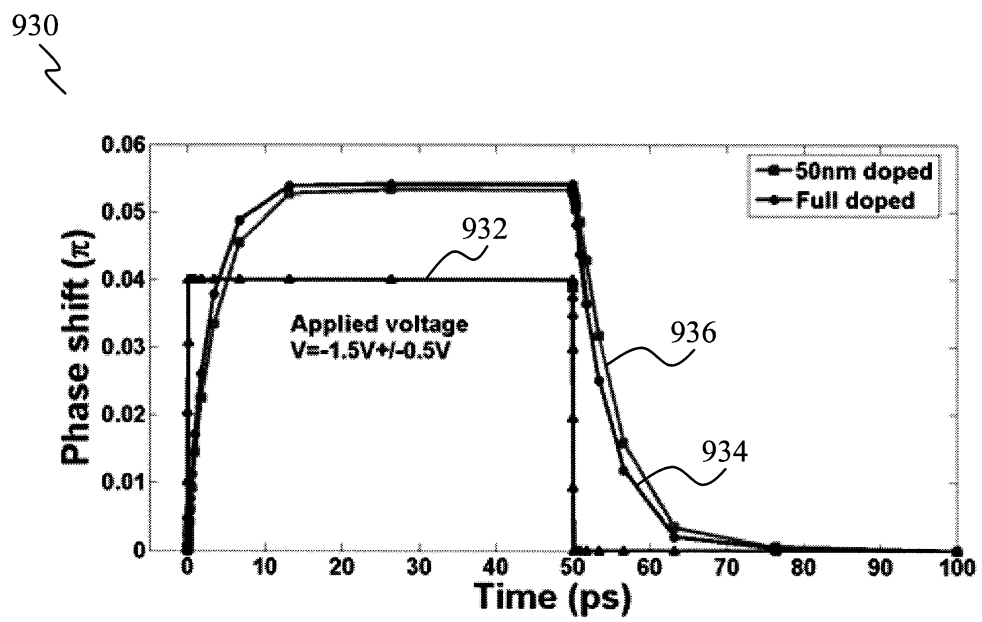


FIG. 9C

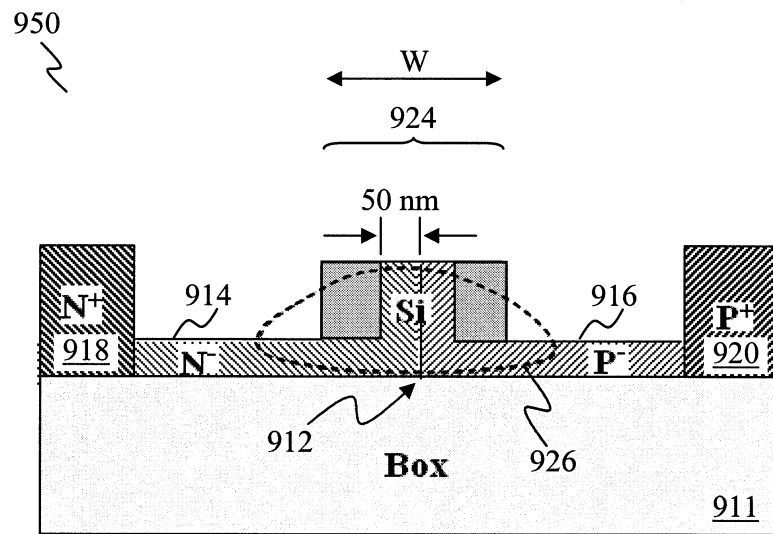


FIG. 9D